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					Yamada et al. Filing Date Group Art Unit						
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Sim		4,013,502	3/22/1977	Staples		156	608	6/18/1973			
1		4,966,663	10/30/1990	Mauger		204	129.3	9/13/1988			
		5,401,932	3/28/1995	Hashimoto et al.		219	69.17	2/3/1993			
Sh		US 6,215,250 B1	4/10/2001	Hirano et al.		315	169.3	8/3/1999			
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		A SE	υ.s	. PATENT	DOCUMENTS					
•EXAMINER INITIAL	REP	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
Gy		6,093,445	07/25/2000	Nawate						
91		4,303,489	12/01/1981	Morrise	on, Jr.					
			U.S. PATEN	T APPLICA	ATION PUBLICATIONS	- <del> </del>				
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Sin	EP 1128449		08-29-2001	CN, EP	, JP, TW, US					
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- 21	PINFORMATION DISCLOSURE CITATION (Use several sheets if necessary)  MAR 3 0 2005				Filing Date Group Art Unit							
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